

FIG. 1

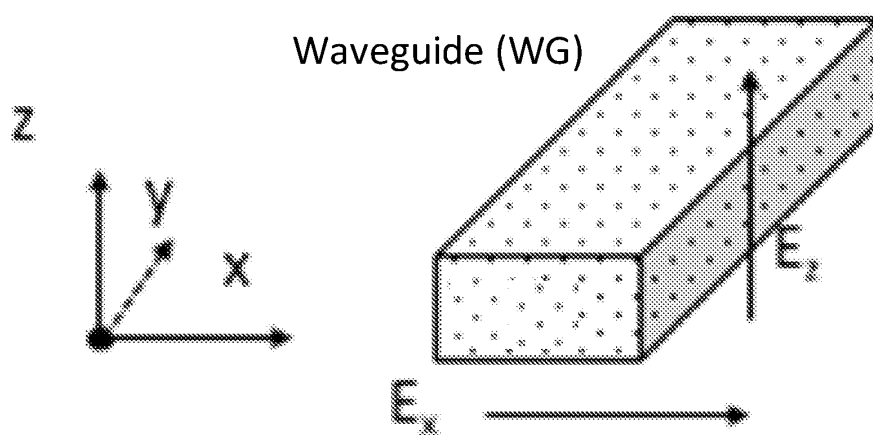


FIG. 2

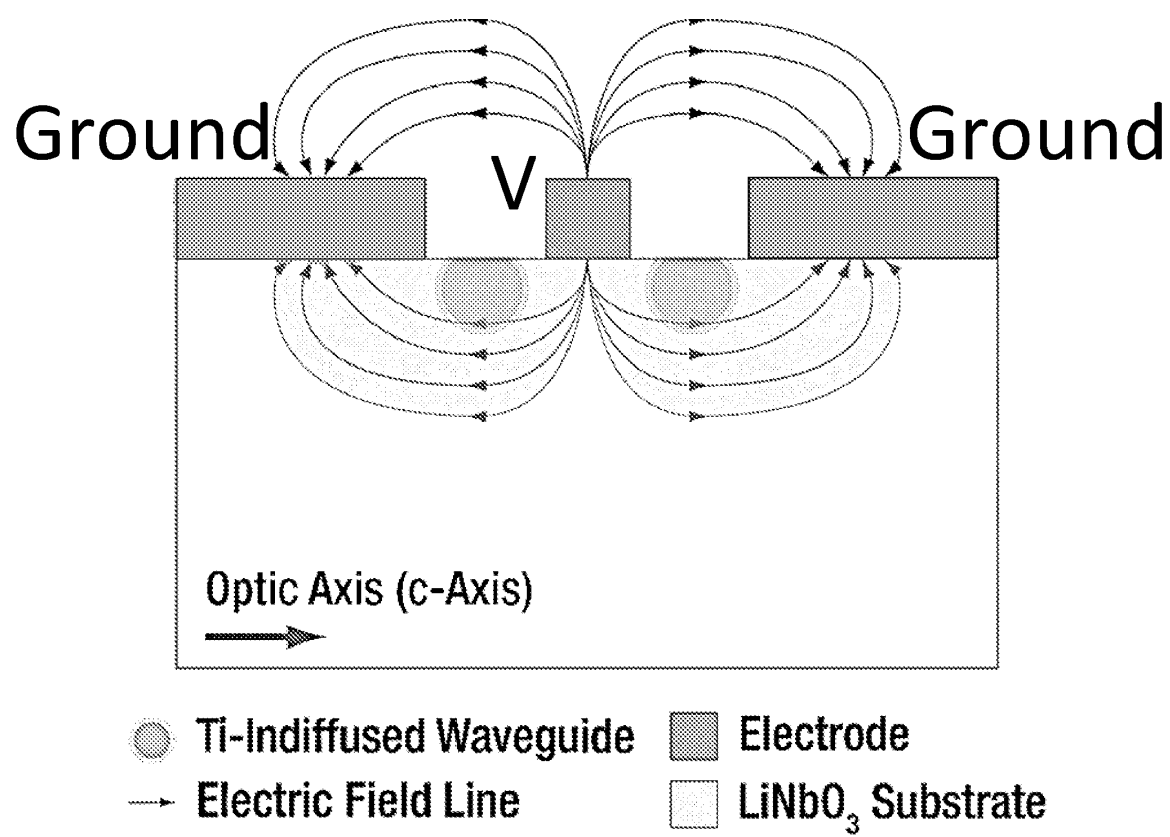


FIG. 3

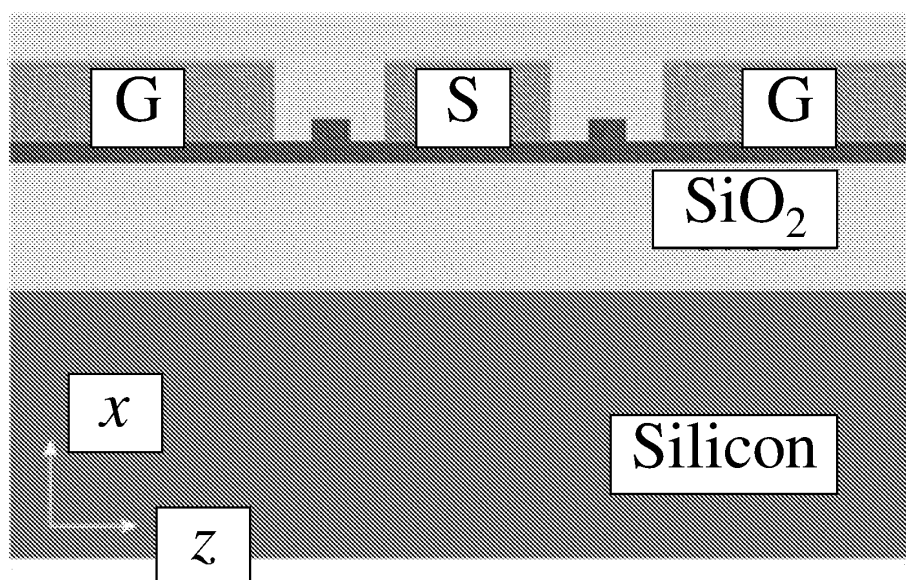


FIG. 4A

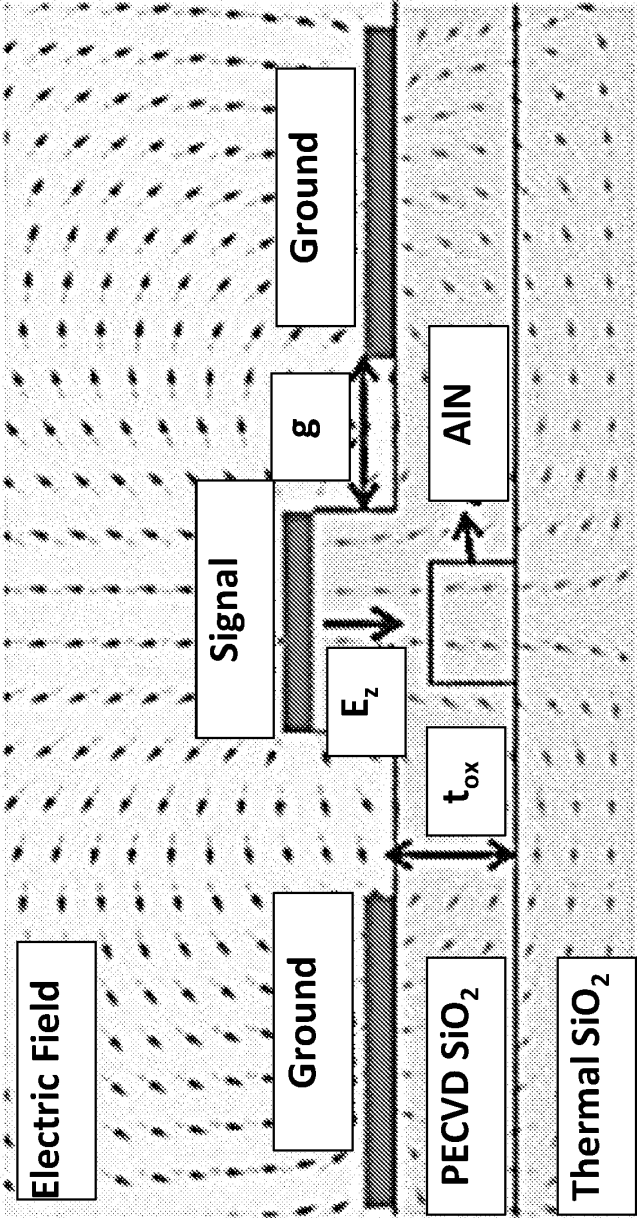


FIG. 4B

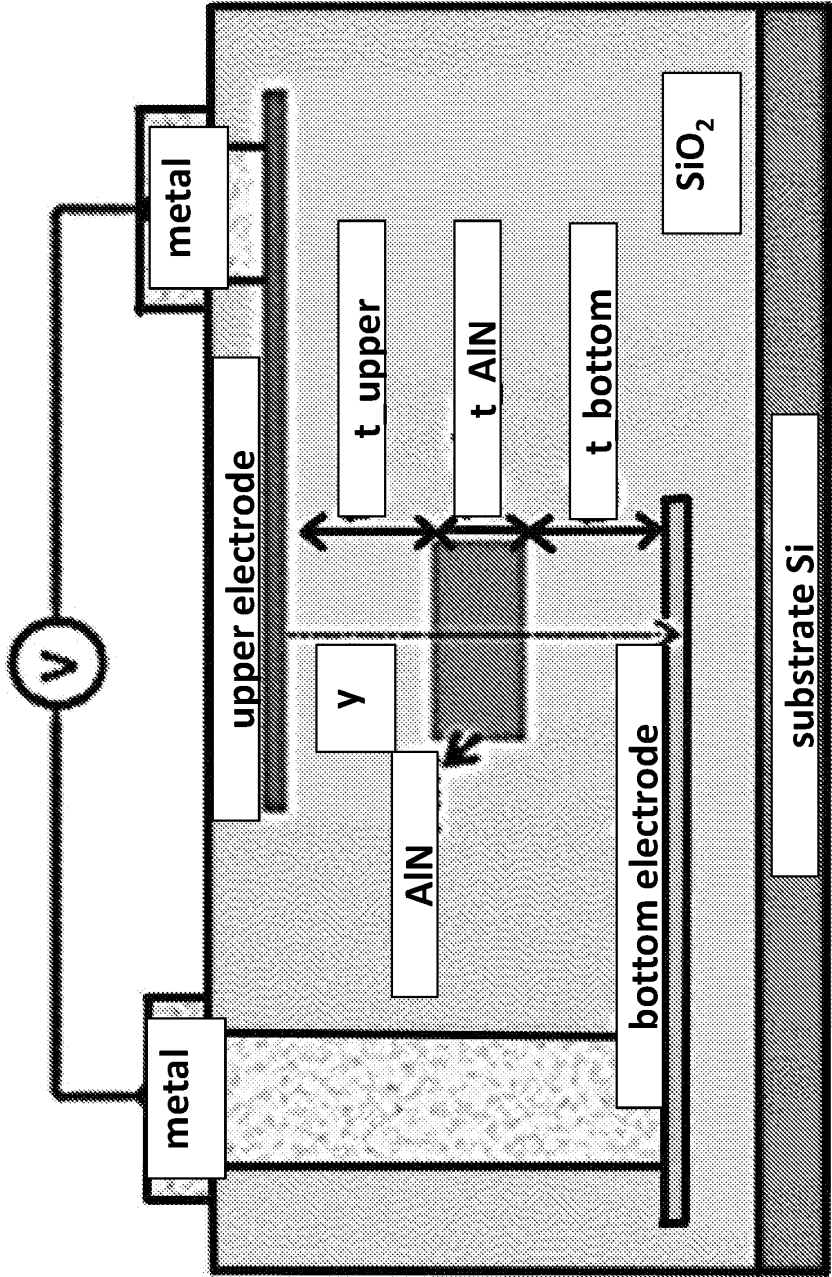


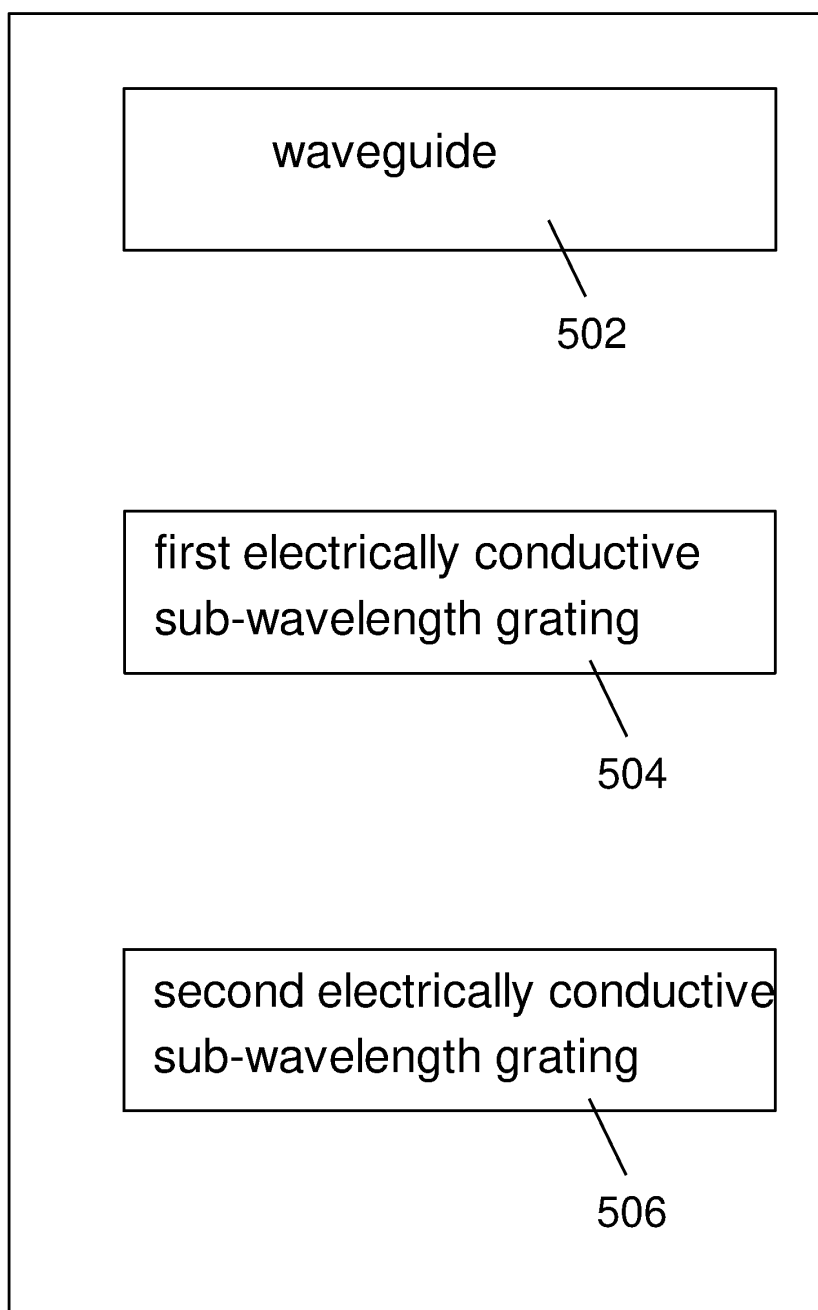
FIG. 5

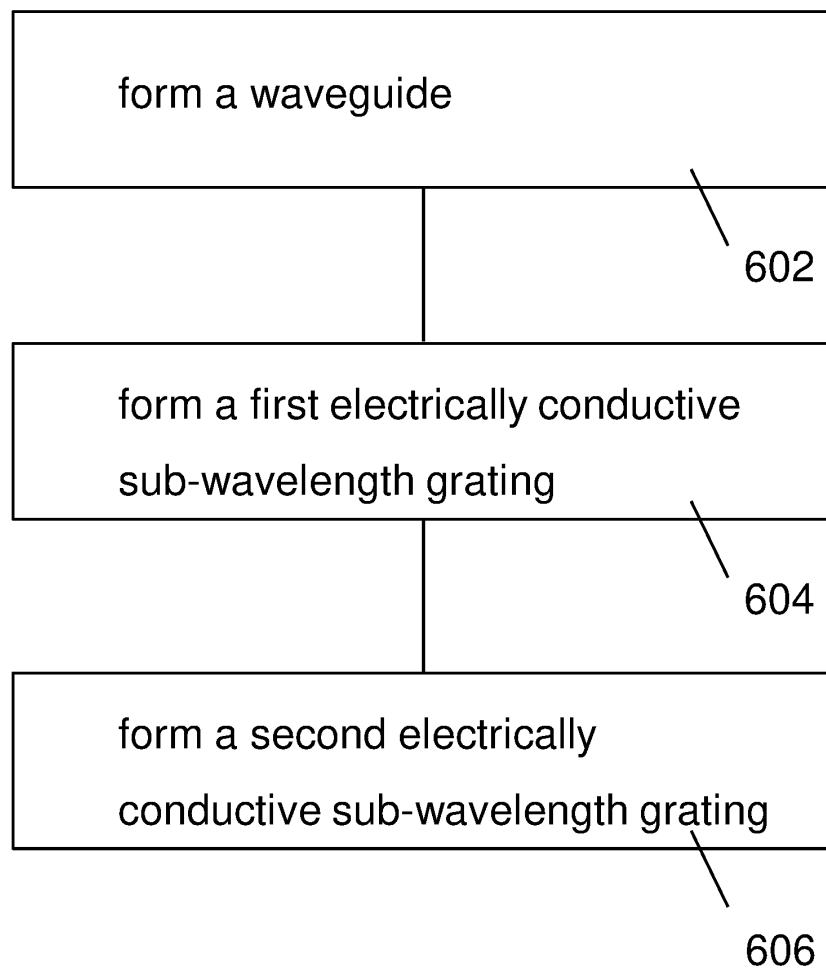
FIG. 6

FIG. 7A

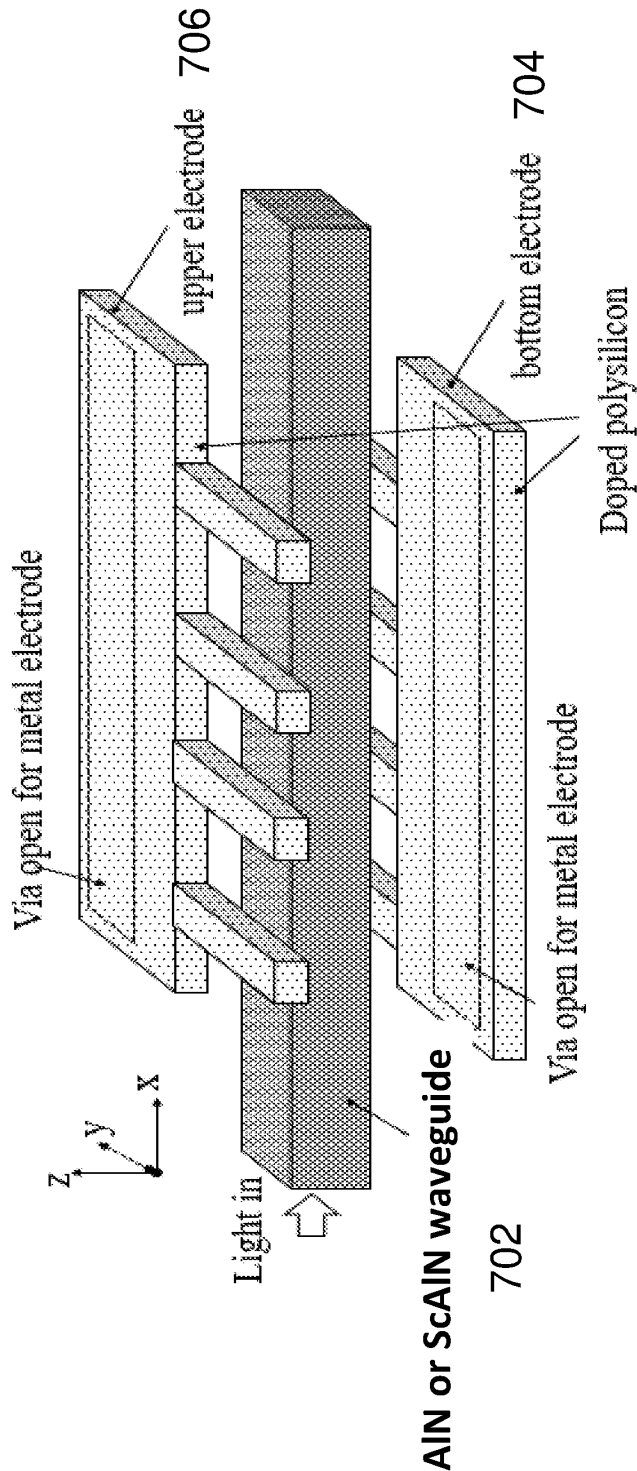


FIG. 7B

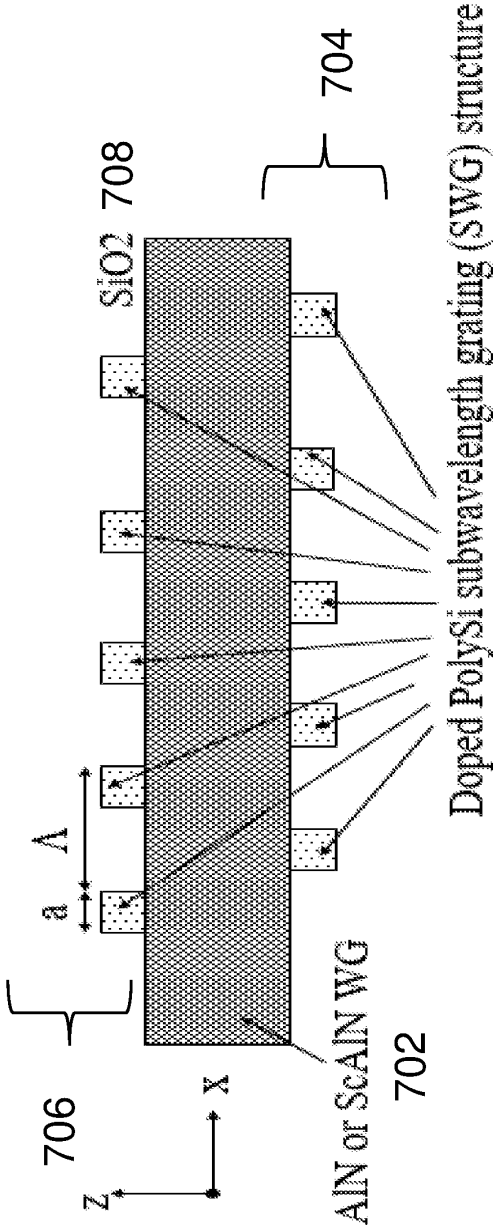


FIG. 7C

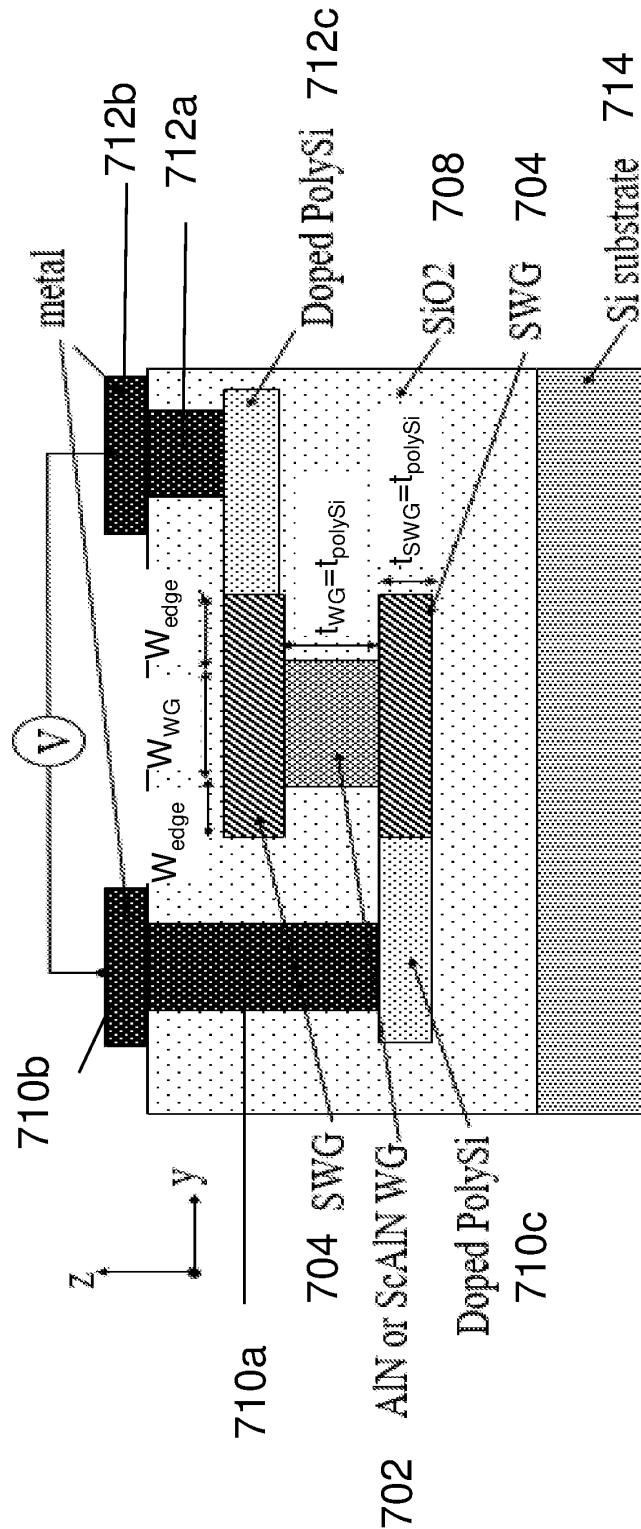


FIG. 8A

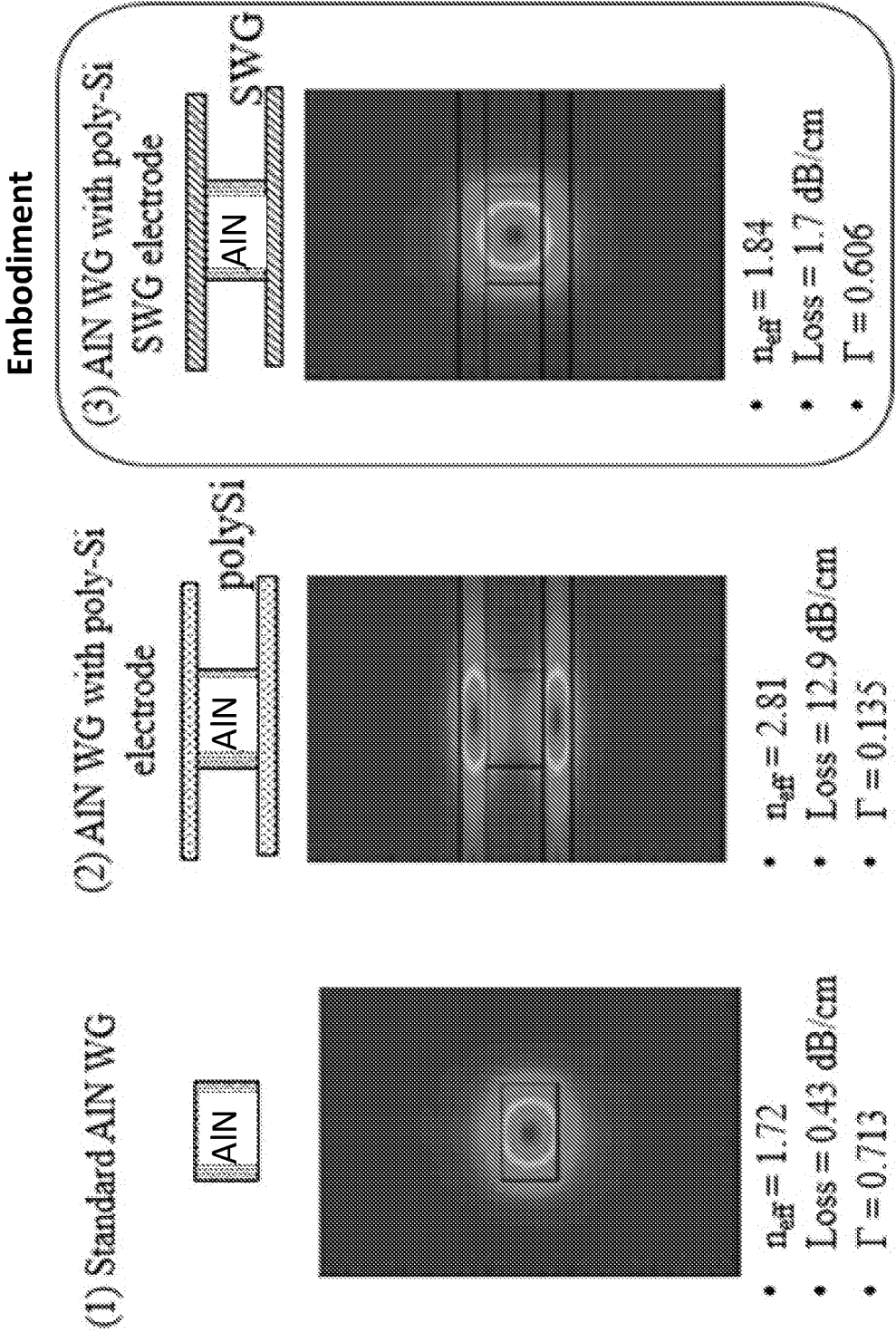
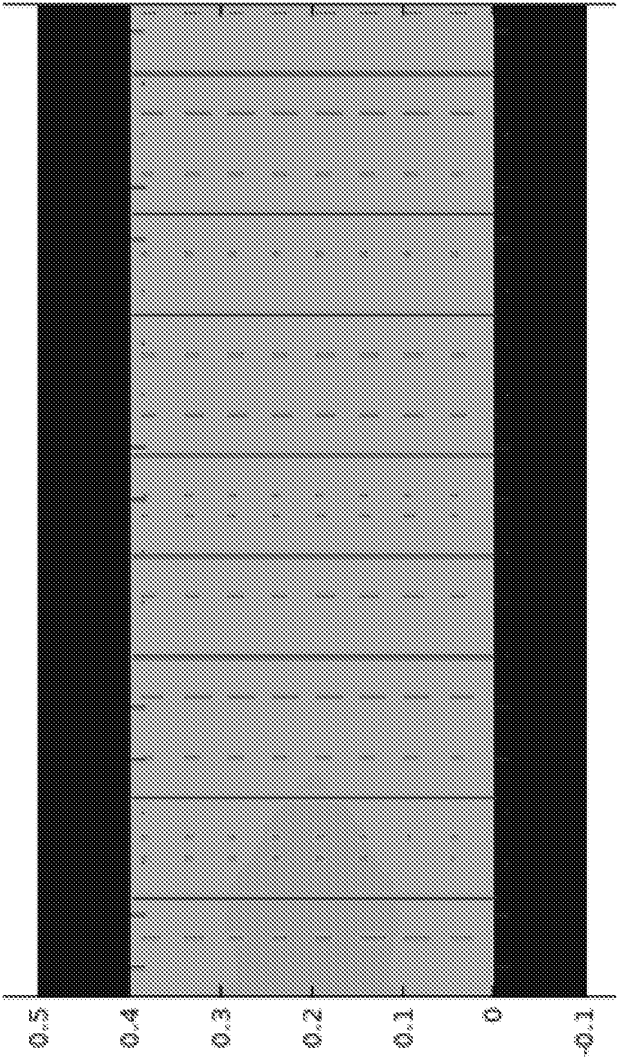


FIG. 8B
Poly-Si plate electrode



When $S=0.4\mu\text{m}$
 $E_z = 2.5 \times 10^6 \text{V/m @ 1V}$

FIG. 8C
Embodiment

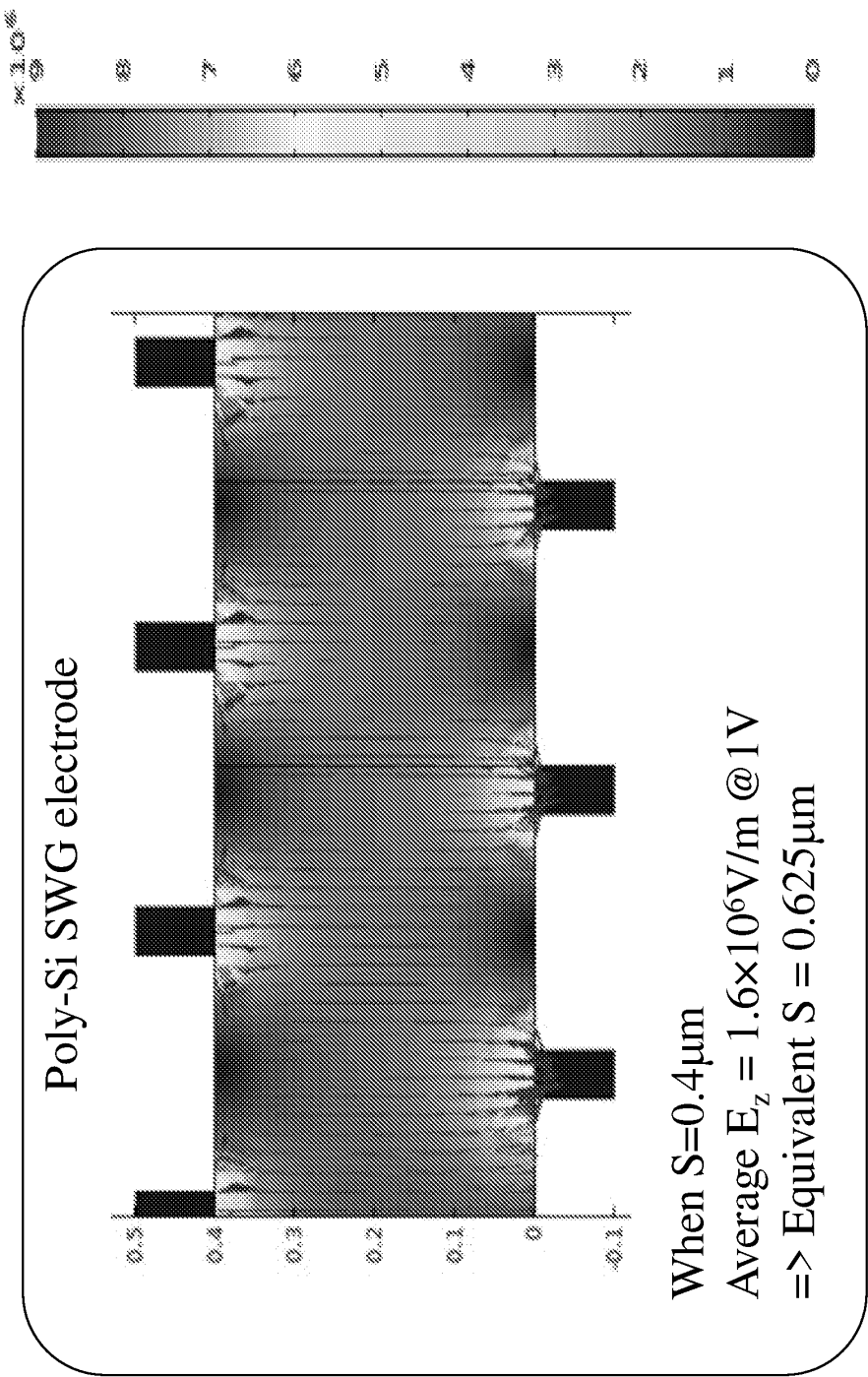


FIG. 9

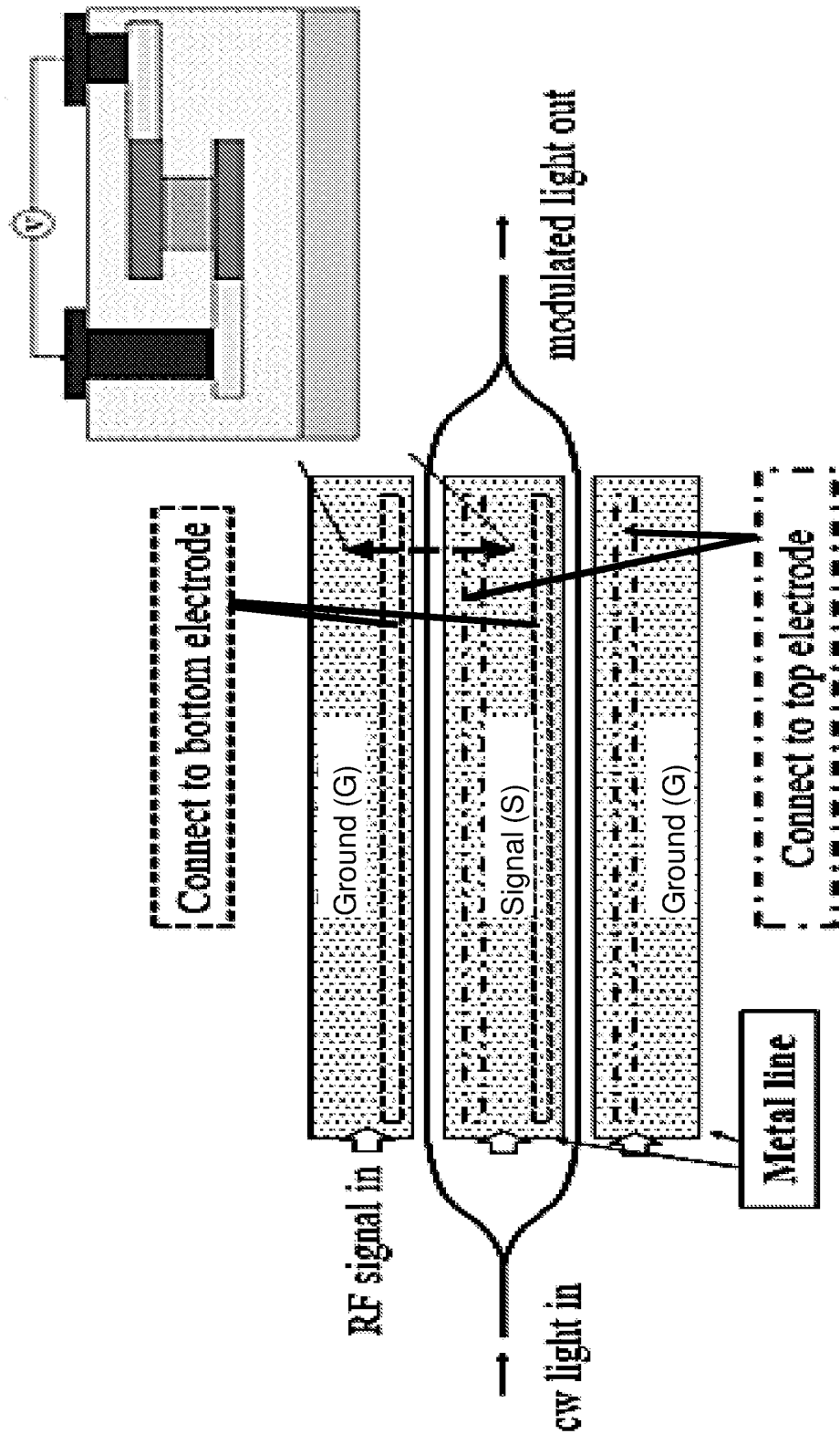


FIG. 10A

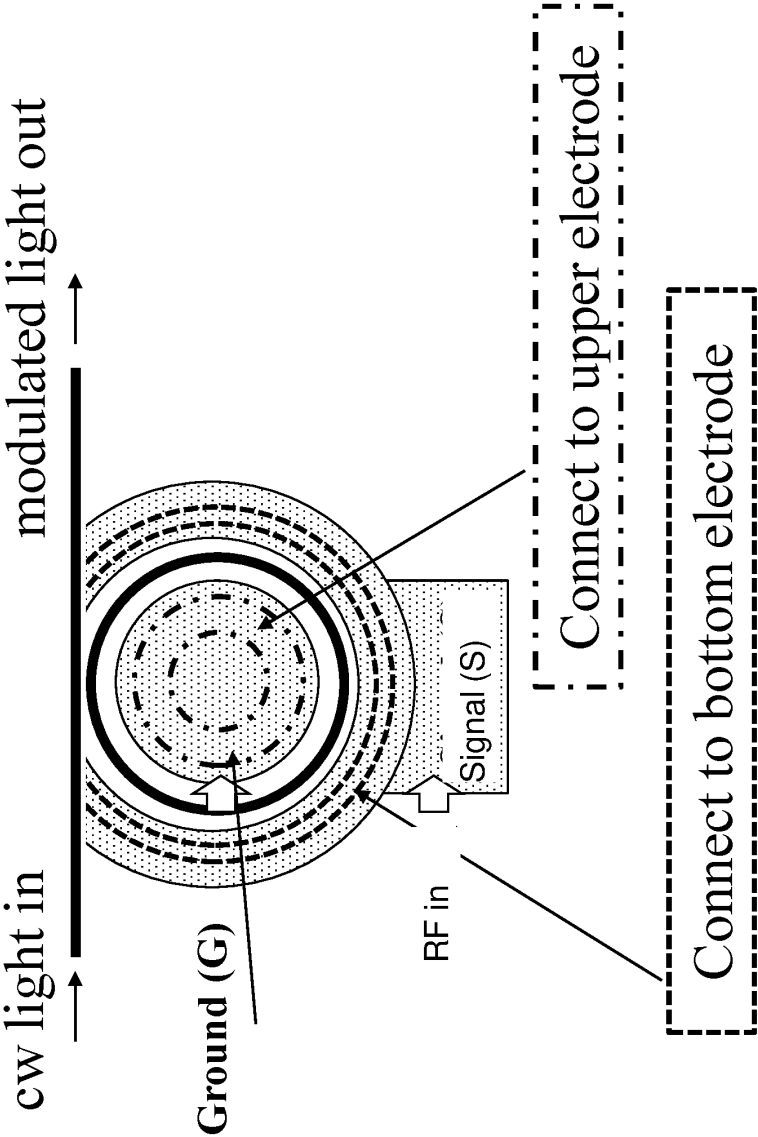


FIG. 10B

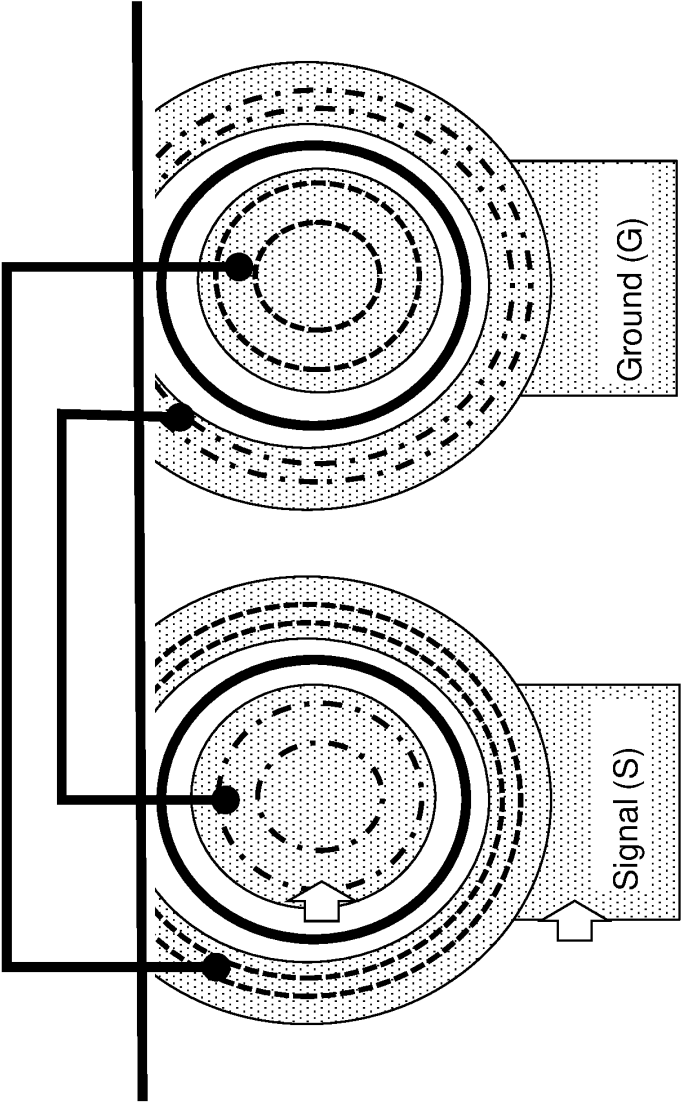


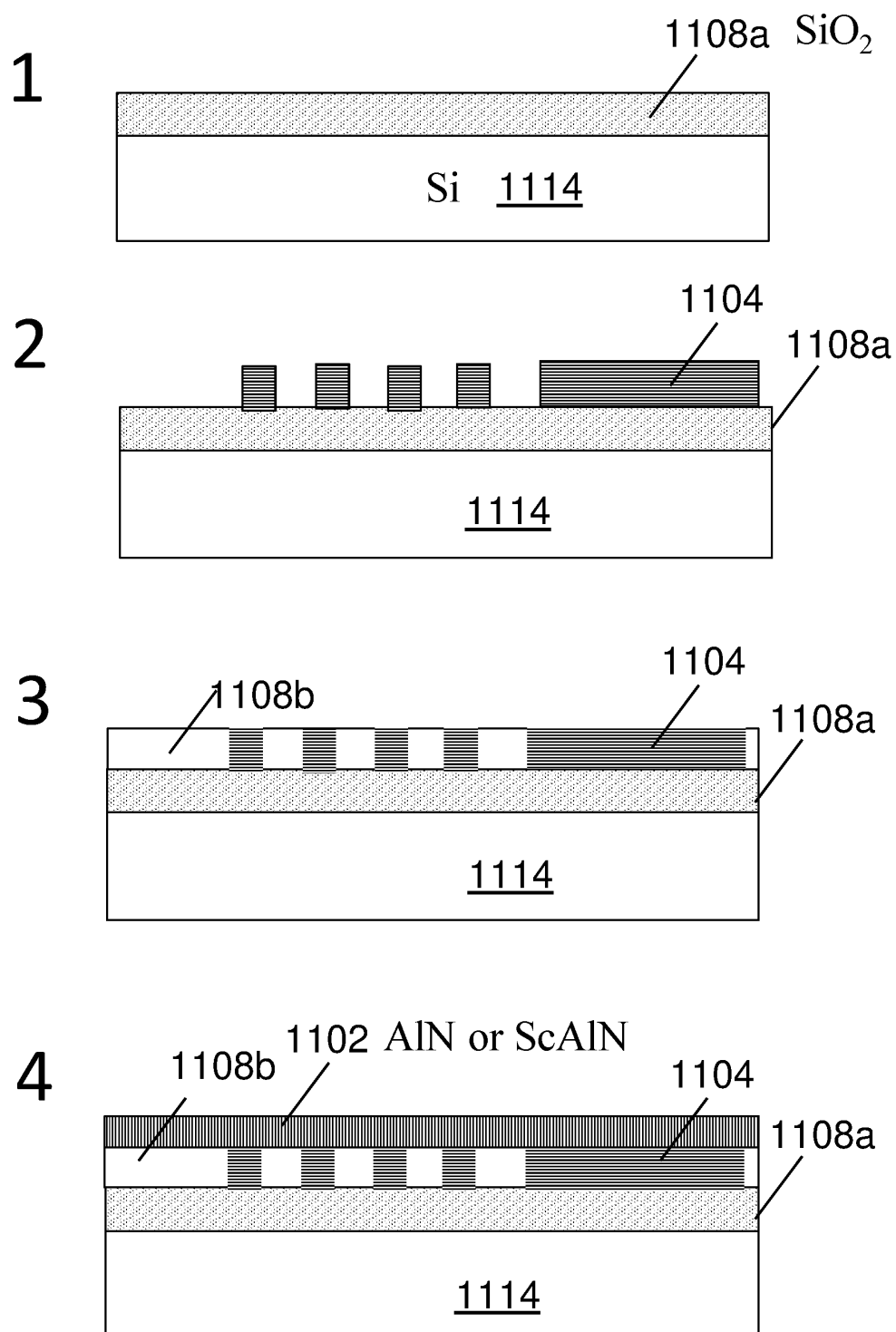
FIG. 11A

FIG. 11B

